



Analog.7403

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Nevin et al.

SERIAL NO: 10/727,449

FILED: December 4, 2003

FOR: METHOD OF FORMING A CAVITY AND SOI IN A SEMICONDUCTOR
SUBSTRATE

Assistant Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

CHANGE OF CORRESPONDENCE ADDRESS

Applicant's representative requests that the correspondence address for the above application be changed to:

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Respectfully submitted,

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I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the Commissioner of Patents and Trademarks, P.O. Box 1450, Alexandria, VA 22313-1450, Mail Stop: Issue fee

Deborah M. Costello

8-24-05
Date